

2813  
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00839.000449

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Erik J. Kielin
ATSUSHI KOIKE, ET AL.	)	
	:	Group Art Unit: 2813
Application No.: 09/982,846	)	
	:	
Filed: October 22, 2001	)	
	:	
For: METHOD FOR FORMING	)	
A DEPOSITED FILM BY	:	
PLASMA CHEMICAL VAPOR	)	
DEPOSITION	:	July 21, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

a) Introductory Comments

In response to the outstanding Official Action dated April 21, 2004, kindly  
consider the remarks for the subject application as follows.

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope addressed  
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-  
1450 on

July 21, 2004

(Date of Deposit)

PETER SAXON (Reg. No. 24947)

(Name of Attorney for Applicant)

Signature

July 21, 2004

Date of Signature